

Setsuo NAKAJIMA et al.

Serial No. 10/706,986

Filed: November 14, 2003

For: METHOD OF FABRICATING

SEMICONDUCTOR DEVICE

Group Art Unit: 2813

Examiner: T. Ngueyn

CERTIFICATE OF MAILING

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2005.

AMENDMENT

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated May 9, 2005, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 12 of this paper.